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INFORMATION DISCLOSURE STATEMENT

FOR	A complex membrane for electrochemical device, manufacturing method and electrochemical device having the same		
Application No.	-	Filing Date	-
Applicant	SAMSHIN CREATION CO., LTD.		
Our Ref.	OV050775US	Your Ref.	-

U.S. PATENT DOCUMENTS (Not Enclosed)

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

Examiner: /John Maples/
Signature:

Date: 05/14/2010
Considered:

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /J.M./